Donald Liebenberg, ONR 312 Office of Naval Researech Ballston Tower One 800 North Quincy Street Arlington, VA 22217-5660 April 11, 1995

ELECTE

OCT 1 7, 1995

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Re:

Contract No.: N00014-94-C-0261, "HTS Josephson Technology on Silicon with

Application to High Speed Digital Microelectronics"

Dear Mr. Liebenberg:

Enclosed is a copy of the Progress Report (0001AF) and Form DD 250 for the above referenced contract.

If you have any questions or if I can be of further assistance, please call me at (203) 528-9806, ext. 130.

Sincerely,

Susan A. White

Administrator of Contracts

and Proposals

Enc.

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1 Rebecca A. Taylor, Contracting Officer

1 Director, Naval Research Laboratory

2 Defense Technical Information Center

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#### MONTHLY PROGRESS REPORT

"HTS Josephson Technology on Silicon with Application to High Speed Digital Microelectronics"

Contract No: N00014-94-C-0261

Office of Naval Research, Arlington, VA

April 11, 1995

**Report No.:** (0001AF)

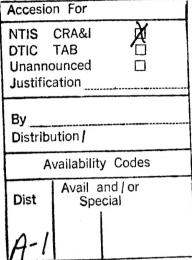
Report Period: March 1 - March 28, 1995

Contract Period: September 30, 1994 - September 29, 1995

Principal Investigator: Peter Rosenthal

AFR No: 531001

**Summary of Progress** 



#### Task 1:Junction fabrication and testing

The last chip, described in the previous monthly report, demonstrated that the Stony Brook scientists were able to fabricate working junctions and SQUIDs from thin YBCO films fabricated on silicon substrates. It was observed that the junctions were not well matched in critical temperatures. This non-uniformity is primarily attributable to non uniformities within the films. To improve the film uniformity, and to accomodate the demands of other projects, we built a new substrate heater for the deposition system, that would provide more uniform temperatures over larger substrate areas. The new heater was built to allow deposition onto 12 mm square chips, which can subsequently be diced into 4 5 mm square chips. With this arrangement, it should be possible to fabricate and test many more junctions from a single deposition and gather more and better statistics on junction properties.

During this month, the AFR PLD facility was down for several weeks while a new substrate heater was installed and broken in. Only one film was sent to Stony Brook for fabrication experiments. They are presently working on fabricating junctions from this chip.

Task 2: Junction modeling

No work was performed in this task.

Task 3: RSFQ device fabrication

No work was performed in this task.

Peter A. Rosenthal. Senior Physicist





## OFFICE OF THE UNDER SECRETARY OF DEFENSE (ACQUISITION) DEFENSE TECHNICAL INFORMATION CENTER **CAMERON STATION** ALEXANDRIA, VIRGINIA 22304-6145

IN REPLY REFER TO

DTIC-OCC

SUBJECT: Distribution Statements on Technical Documents

TO:

OFFICE OF NAVAL RESEARCH CORFORATE PROGRAMS DIVISION

ONR JUB

800 NORTH QUINCY STREET ARLINGTON, VA 22217-5660

- 1. Reference: DoD Directive 5230.24, Distribution Statements on Technical Documents, 18 Mar 87.
- 2. The Defense Technical Information Center received the enclosed report (referenced below) which is not marked in accordance with the above reference.

PROGRESS REPORT ADVANCE FUEL RESEARCH N00014-94-C-0261 TITLE: HTS JOSEPHSON TECHNOLOGY ON SILICON WITH APPLICATION TO HIGH SPEED DIGITAL

- 3. We request the appropriate distribution statement be assigned and the report returned to DTIC within 5 working days.
- 4. Approved distribution statements are listed on the reverse of this letter. If you have any questions regarding these statements, call DTIC's Cataloging Branch, (703) 274-6837.

FOR THE ADMINISTRATOR:

1 Encl

**GOPALAKRISHNAN NAIR** Chief, Cataloging Branch

FL-171 **Jul 93** 

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